

<b>Notice of References Cited</b>	Application/Control No. 10/723,898	Applicant(s)/Patent Under Reexamination MEAD ET AL.	
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*	B	US-2003/0103017	06-2003	Kawase, Tomomi	345/30
*	C	US-2003/0008959	01-2003	Crabb et al.	524/399
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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